IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Applicant:

VAN BUSKIRK et al.

Application No.: -09/929,860

09928860

Date Filed:

August 13, 2001

Title:

SCALABLE LEAD ZIRCONIUM

TITANATE (PZT) THIN FILM MATERIAL AND DEPOSITION

METHOD, AND

FERROELECTRIC MEMORY

DEVICE STRUCTURES COMPRISING SUCH THIN

FILM MATERIAL

Docket No.:

2771-357 DIV

Examiner:

FULLER, Eric B.

Art Unit:

1762

Confirm. No.:

8391

Customer No.:

EXPRESS MAIL CERTIFICATE

I hereby certify that I am mailing the attached documents to the Commissioner for Patents on the date specified, in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, and Express Mailed under the provisions of 37 CFR 1.10.

March 1, 2004 Date

EV 160595211 US Express Mail Label Number

AMENDMENT RESPONDING TO DECEMBER 1, 2003 OFFICE ACTION IN UNITED STATES PATENT APPLICATION NO. 09/928,860

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This responds to the December 1, 2003 Office Action in the above-identified application. Please amend the claims as set out in the following Section I (Amendments to the Claims). Remarks addressing the substance of the December 1, 2003 Office Action and amendments made herein are set out in Section II (Remarks) hereof.

03/15/2004 WABDELR1 00000009 09928860

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